

10/549900  
JC17 Rec'd PCT/PTO 20 SEP 2005

03500.017975.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
	:	Examiner: Not Yet Assigned
SHUNICHI ISHIHARA	)	
	:	Art Unit: Not Yet Assigned
Application No.: Not Yet Assigned	)	
Nati'l. Pharse of PCT/JP2004/004072	:	
filed March 24, 2004	)	
Filed: Concurrently Herewith	:	
	)	
For: SOLAR CELL	:	September 19, 2005

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed foreign documents are also enclosed.


It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

10/549900

JC17 Rec'd PCT/PTO 20 SEP 2005

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



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FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)				ATTY DOCKET NO. <b>03500.017975</b>		APPLICATION NO. <b>National. Phase of          PCT/JP2004/004072 filed          3/24/04 10/549900</b>	
				APPLICANT <b>SHUNICHI ISHIHARA</b>			
				FILING DATE <b>Concurrently Herewith</b>		GROUP <b>N.Y.A.</b>	
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		5,403,771	04/04/95	Nishida et al.	437	89	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
	JP	3-228324	10/09/91	Japan	H01L	21/208	Abstract
	JP	2001-217442A	08/10/01	Japan	H01L	31/04	Abstract
	JP	2001-332494A	11/30/01	Japan	H01L	21/20	Abstract
	JP	9-312258	12/02/97	Japan	H01L	21/20	Abstract
	JP	04-225282	08/14/92	Japan	H01L	31/04	Abstract
	JP	10-107302	04/24/98	Japan	H01L	31/04	Abstract
	JP	2001-237446A	08/31/01	Japan	H01L	31/04	Abstract
	JP	5-36611	02/12/05	Japan	H01L	21/205	Abstract
	W0	92/12542	07/23/92	EPO	H01L	31/18	Abstract
	DE	41 93 392 T1	12/10/92	Germany	H01L	31/0392	Abstract
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
		<b>"Investigation of Polycrystalline Silicon Deposition on Glass Substrates", Zhengrong Shi et al., Solar Energy Materials and Solar Cells 31 (1993) 51-60, Holland, pgs. 51-60</b>					
EXAMINER				DATE CONSIDERED			

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.